

Application/Control No.	Applicant(s)/Patent under Reexamination	er
10/716,871	KIM ET AL.	
Examiner	Art Unit	
Huyen X. Vo	2626	

SEARCHED				
Class	Subclass	Date	Examiner	
704	270; 276	4/22/2007	н∨	
379	202.01	4/22/2007	HV	
379	203.01	4/22/2007	HV	
705	27	4/22/2007	HV	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
		-		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
EAST search included	4/22/2007	н۷	